(F)

AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Howard Ge et al.						Docket No. 34261-8500	
Application No.	Filing Date	Examiner		Customer N	0.	Group Art Unit	Confirmation No.
10/680,960	October 7, 2003	Chacko Davis, Daborah		21611		1756	6075
Invention: OPHOTORESIST COATING PROCESS FOR MICROLITHOGRAPHY MAR 0 9 2007							
COMMISSIONER FOR PATENTS:							
Transmitted herev	vith is an amendment i	n the above-identified a	pplication	on.			
The fee has been calculated and is transmitted as shown below.							
. CLAIMS AS AMENDED							
-	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR		ER EXTRA		RATE	ADDITIONAL FEE
TOTAL CLAIMS	18 -	20 =		0	x	\$50.00	\$0.00
INDEP. CLAIMS	3 -	3 =		0	X	\$200.00	\$0.00
Multiple Dependent Claims (check if applicable)							\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT \$0.00							
 No additional fee is required for amendment. □ Please charge Deposit Account No. in the amount of □ A check in the amount of to cover the filing fee is enclosed. ☑ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 19-2814 ☑ Any additional filing fees required under 37 C.F.R. 1.16. ☑ Any patent application processing fees under 37 CFR 1.17. □ Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038. 							
Albin H. Gess Registration No. 2 SNELL & WILM 600 Anton Blvd., Costa Mesa, Calif Tel. (714) 427-779 Fax (714) 427-779	ER LLP Suite 1400 fornia 92626 20	<u>C</u>	ERTIFIC I hereby with the "Expres	ATE OF MAIL (certify that the United States I is Mail No. EV missioner for Occh 9 Date	INC fol Post Pat	G BY "EXPRESS lowing correspon al Service with su 2232 89 51 ents. P.O. Box 1	150, Alexandria, VA
cc:			M	ARC FA		•	



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Patent Examiner: Chacko Davis, Daborah

Howard Ge, et al.

Group Art Unit: 1756

Serial No.: 10/680,960

Confirmation No.: 6075

Filed: October 7, 2003

Title: PHOTORESIST COATING PROCESS

FOR MICROLITHOGRAPHY

March 9, 2007

Costa Mesa, California 92626

RESPONSE TO OFFICE ACTION

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Responsive to the Office Action of December 11, 2006, kindly amend the above-identified application as follows: